

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	2	"6344150".pn.	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/02 15:51
S2	2	2002-501468	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/02 15:53
S3	1	"2002501468"	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/02 15:53
S4	0	205/640.ccls. and (ferroelectric) same (etch etch\$3)	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/02 16:32
S5	1	205/640-686.ccls. and (ferroelectric) same (etch etch\$3)	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/02 16:33
S6	1	("5589083").PN. OR ("6344150").URPN.	US_PGPUB; USPAT; USOCR	OR	ON	2008/05/06 12:32
S7	0	205/640-686.ccls. and (ferroelectric) with (etch etch\$3)	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:35
S8	6	(205/640-686.ccls. 216/24.ccls.) and (ferroelectric) with (etch etch\$3)	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:36

S9	1	S8 and (stir stir\$3)	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:38
S10	0	205/640-686.ccls. and (LiNbO3) with (etch etch\$3)	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:39
S11	0	205/640-686.ccls. and (LiNbO3) with (etch etch\$3 polish polish\$3 electroetch electroetch\$3 electropolish electropolish\$3)	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:39
S12	1	205/640-686.ccls. and (LiNbO3 ferroelectric) with (etch etch\$3 polish polish\$3 electroetch electroetch\$3 electropolish electropolish\$3)	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:40
S13	2	205/640-686.ccls. and (LiNbO3 ferroelectric) same (etch etch\$3 polish polish\$3 electroetch electroetch\$3 electropolish electropolish\$3)	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:40
S14	11	205/640-686.ccls. and (LiNbO3 ferroelectric) and (etch etch\$3 polish polish\$3 electroetch electroetch\$3 electropolish electropolish\$3)	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:41

S15	0	205/640-686.ccls. and (LiNbO3 ferroelectric) and (etch etch\$3 polish polish\$3 electroetch electroetch\$3 electropolish electropolish\$3) same ((stir stir\$3) and (filter filter\$3))	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:41
S16	10	205/640-686.ccls. and (silicon semiconductor microelectronic micropiece workpiece) and (etch etch\$3 polish polish \$3 electroetch electroetch\$3 electropolish electropolish\$3) same ((stir stir\$3) and (filter filter\$3))	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:42
S17	9	205/640-686.ccls. and (etch etch\$3 electroetch electroetch\$3) same ((stir stir\$3) and (filter filter\$3))	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:45
S18	36	205/640-686.ccls. and (etch etch\$3 electroetch electroetch\$3) and ((stir stir\$3) and (filter filter\$3))	US_PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/05/06 12:46

5/6/2008 2:07:43 PM

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